Device for In-Situ Coating of Long, Small Diameter Tubes
Final Report
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H. Joe Poole, President
PVI System Technology
Oxnard, California
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Outline

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Program Goals

• Develop an *in situ* coating method for long, small diameter (2.75” ID) tubes. Goal was accomplished.

• Reduce secondary electron yield (SEY) to suppress electron cloud formation. Goal was accomplished.

• Reduce RF resistivity to reduce ohmic heating. Goal was accomplished.

Approach: Cylindrical Magnetron Sputtering
Summary

• All project objectives were met and/or surpassed.
• Breakthrough technologies were developed to enable in-situ copper coating of long, small diameter stainless steel tubes with limited number access points, which are about 500 meters apart.
• Coating adhesion met and/or exceeded industrial bonding tests. Two US patents, for newly developed technologies, were applied for.
Summary

• A magnetron with a 50 cm long copper cathode was designed fabricated (cooling and weight limits the length), and successfully operated to coat an assembly containing a tube of a full-size, stainless steel, cold bore, Relativistic Heavy Ion Collider (RHIC) magnet tubing connected to two types of RHIC bellows.

• To increase cathode lifetime, movable magnet package is used, and thickest possible cathode was made, with a target to substrate distance of less than 1.5 cm.

• The magnetron, mounted on a carriage with spring loaded wheels successfully crossed bellows and adjusted for variations in vacuum tube diameter.
Summary

• Room temperature RF conductivity measurements were made using resonant cavities. These measurements indicated that the conductivity of the copper coating was about 84% of the known value of pure copper. Since joints and connectors reduce experimentally measured Q, conductivity value of coatings may be even closer to pure solid copper.

• RF resistivity measurements must be repeated at cryogenic temperatures. PVI is working on a Phase 1 SBIR project to develop a system to measure RF resistivity at cryogenic temperatures.
Design and Results using 2nd Generation Deposition Source
Umbilical drive mechanism
Umbilical drive assembly
In-situ coating system
Coating of RHIC Bellows and Tubes
Coating of RHIC Bellows and Tubes (cont.)
Next Steps

- Ongoing development of thin film coatings for accelerators & related components.
- Development of test system to measure RF resistivity at cryogenic temperatures.